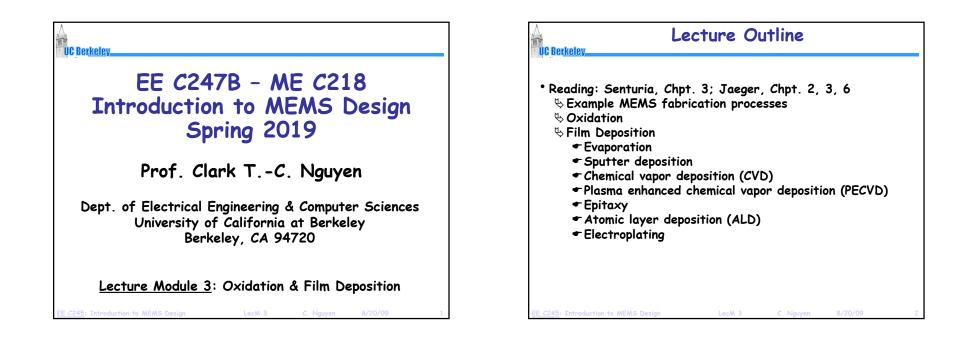
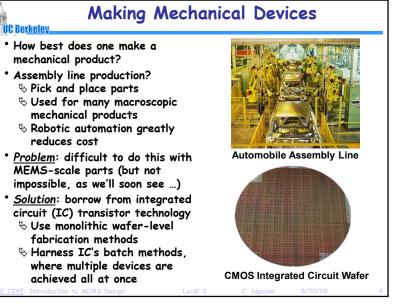
<u>EE 247B/ME218</u>: Introduction to MEMS Design Lec5m2: Oxidation & Film Deposition

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